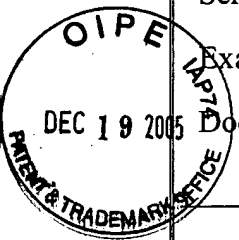




IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Yee-Chung Fu  
Assignee: Advanced Nano Systems, Inc.  
Amended Title: MEMS Scanning Mirror with Trenched Surface and Tapered Comb Teeth for Reducing Inertia and Deformation  
Serial No.: 10/779,952 Filing Date: February 13, 2004  
Examiner: Allan R. Wilson Group Art Unit: 2815  
Docket No.: ANS-P105



San Jose, California  
December 15, 2005

Mail Stop RCE  
COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

**AMENDMENT**

Dear Sir:

In response to the August 18, 2005 Notice of Drawing Inconsistency with Specification, please amend the above-identified application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Remarks** begin on page 3 of this paper.